

BW-S500

Super High Vertical Resolution Non-Contact 3D Surface Profiler

BW-D500 Series Nikon's proprietary scanning-type optical interference measurement technology achieves **1pm*** height resolution.

* Height resolution specified by algorithm

Quickly and accurately measures surface profile from sub-nano to millimeter height ranges, using a single measurement mode. Fully supports high-precision processing technology and advanced material development of the Materials Science field.



General-purpose model with high-pixel resolution that measures both smooth and rough surfaces.

Delivers super high-resolution height measurement with 4.19 Mpixel high-resolution camera



Six models available to match application and cost

Both the BW-S and BW-D are available in the six types shown below.

	Piezo driven		Scanning			
	Objective lens drive	Nosepiece drive	Z axis		XY axis	
			Manual	Electric	Manual	Electric
BW-S501/D501	0		0		0	
BW-S502/D502	0			0	0	
BW-S503/D501	0			0		0
BW-S505/D505		0	0		0	
BW-S506/D506		0		0	0	
BW-S507/D507		0		0		0



Electric XY axis 503/507 Enables wide-area analysis through the stitching of multiple height images.

Nosepiece drive piezo

505/506/507

Allows easy switching of objective lens magnification.





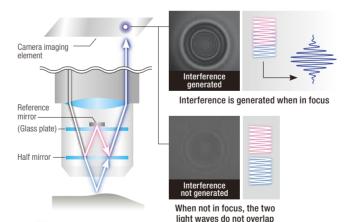
High-precision/high-speed image

acquisition via a two beam interference objective lens

The BW-S500 / D500 series uses a two beam interference objective lens and Nikon's proprietary algorithms to acquire height images with high speed and precision.



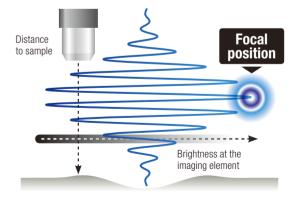
By overlaying the light returning from the reference mirror inside the objective lens and the light returning from the sample, the two beams overlap at the focal position and create interference.





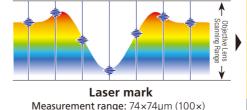
Focal position is determined with high precision from the interference waveform

The brightness of the interference is highest at the focal position (0order interference position). The two beam interference objective lens is moved gradually by a piezo mechanism, and the position of greatest brightness is detected simultaneously and with ultra precision by all of the imaging elements

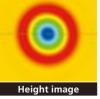


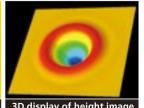


The focal position information acquired by each imaging element is mapped, and the surface profile of the sample is depicted in pseudocolor



Height range: 2µm



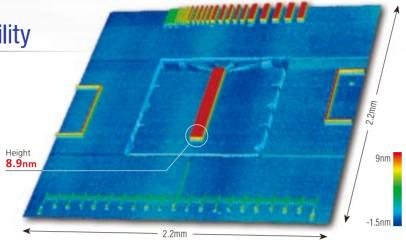




High Traceability and Repeatability

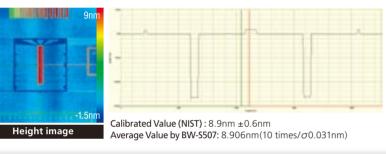
The BW-S500/BW-D500 series is calibrated by an 8nm or 8µm VLSI Step Height Standards sample, certified by the NIST. Achieves extremely high accuracy and repeatability as a height measurement system.





8nm Step Height Sample

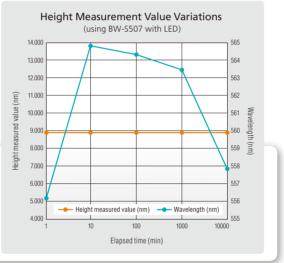
VLSI (8nm Step Height Sample)





With Nikon's proprietary technology, measurement values with the BW-S500/BW-D500 series are independent of central wavelength of light source.

Measurements can be done immediately after switching on illumination source.



Wide region configuration analysis with stitching

Electric XY stage and "Digital Stylus Imager 3" software allow stitching with BW-S503/507 and BW-D503/507.

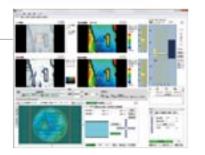
Adjustment of

height display range

Stitching can be done in both vertical and horizontal direction.

Stitching of acquired images

(at 5×5 FOV)

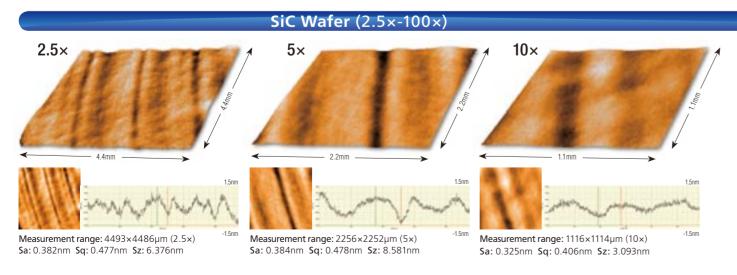


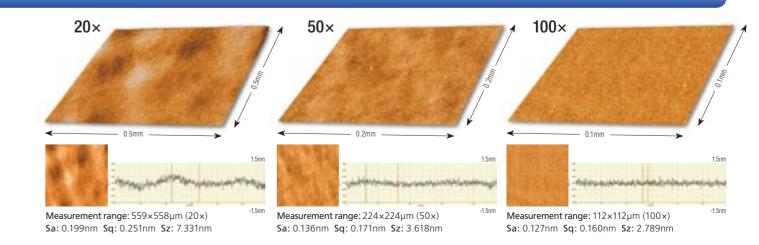
Coin (5×5 Stitching) One-shot image Automatic acquisition of specified shot images 54µm 20µm

Capable of ø20mm order wide region stitching at 10µm order range.

1pm height resolution achieved at magnifications from $2.5 \times$ to $100 \times$

Ultra high-precision allows for measurement of grade-0.1nm 3D roughness Sa from minimum magnification (4.4mm) to maximum magnification (111µm).



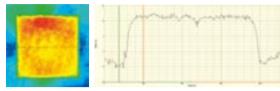


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Analytical software spanning basic measurement to advanced analysis

Image Transformer

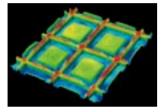
Performs automatic measurement of distance, height and angle between two points specified by the cursor, as well as two-dimensional roughness (Ra, Rg, Rz) / three-dimensional roughness (Sa, Sg, Sz)



Display of cross-section profile and measurement results at position specified on the height image

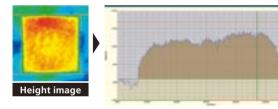
3DViewer

The acquired height image is displayed in 3D.



Geometric Parameter Measurement

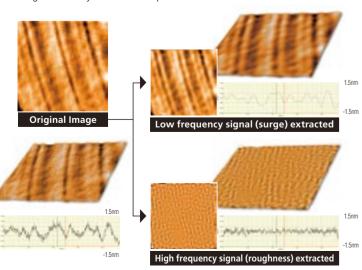
Through area and volume measurement of an irregular portion, as well as simultaneous analysis of the shapes of multiple irregular portions, uniformity and unevenness can be ascertained.



Display of the volume and area of specified indentations and protrusions

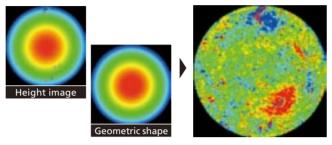
Surface Texture Analyzer

The low frequency / high frequency components of the height image are sampled, revealing approximate surface profile and allowing roughness analysis of detailed portions.



Zernike Polynomial Analyzer

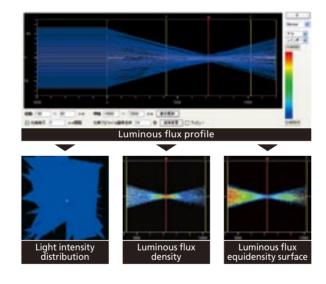
From the height image of a spherical sample, the ideal spherical surface curve (geometric shape) for the sample's form is calculated, allowing analysis of the sample's surface roughness.



The height image and the calculated geometric shape are compared, and surface roughness is detected

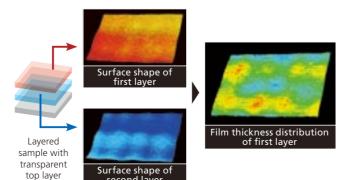
Optical Ray Tracer

From a simulation of light rays when light is shone on the backside of a lens-shaped sample, light intensity distribution, luminous flux density, and other data can be analyzed for the specified cross section.



Layer Thickness Analyzer

Analysis of transparent films can be performed to ascertain the surface shape of each layer and investigate the film thickness distribution. Measurement of multiple layers is possible

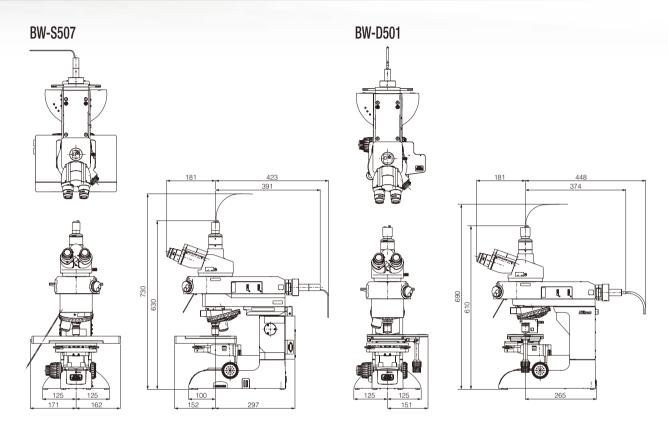


BW-S501 | BW-S502 | BW-S503 | BW-S505 | BW-S506 | BW-S507 Optical Microscope Unit BW-LV150N BW-FMA BW-LV150N BW-FMA BW-LV150N BW-FMA BW-LV150N BW-FMA Piezo Driven Objective lens driven Nosepiece driven Objective lens driven Nosepiece driven Piezo Scanning Range 100µm Z Axis Electric (standard Electric (standard Electric (standard Electric (standard Manual Manual stroke 20mm) stroke 20mm) stroke 20mm) stroke 20mm) XY Axis Electric Electric Electric Electric (standard (standard (standard (standard Manual Manual travel range travel range travel range travel range 130×85mm 130×85mm 130×85mm 130×85mm Computer High-performance specifications for BW Software Bridgelements⁶ CMOS USB 3.0 camera High-speed camera **Imaging Camera Number of Pixels** 2046×2046, 1022×1022 (selectable via software) 510×510 Objective Lens Two beam interference objective lens $(2.5\times, 5\times, 10\times, 20\times, 50\times, 100\times)$ Observation and Measurement Range (Two Beam Interference Objective Lens 1 Field of View 50× 100× 2.5× 10× 2.5× Horizontal (H) µm 4448 2224 1112 556 222 111 2015 1007 503 251 100 50 1007 Vertical (V) µm 2224 1112 222 111 2015 503 251 100 50 Working Distance (mm) 10.3 9.3 7.4 4.7 3.4 2.0 10.3 9.3 7.4 4.7 3.4 2.0 Numerical Aperture (NA) 0.075 0.13 0.3 0.4 0.55 0.7 0.075 0.13 0.3 0.4 0.55 0.7 Focal Depth (µm) 16.2 3.03 1.71 0.90 0.56 48.5 3.03 0.90 48.5 16.2 1.71 0.56 Pixel Resolution 1.09 0.55 0.28 0.11 0.06 3.96 1.98 0.99 0.50 0.20 0.10 0.55 0.22 0.11 2.18 1.09 Optical Resolution (µm) 4.56 2.63 1 14 0.86 0.63 0.49 4.56 2.63 1.14 0.86 0.63 0.49 Measurement Optical System White light interferometry Algorithmically-specified 1pm (0.001nm) **Height Resolution** Effective Height Resolution 15pm (0.015nm) *When anti-vibration table is in environment not exceeding Vibration Criterion VC-C Step Measurement Reproducibility σ:8nm (8um step measurement) *When anti-vibration table is in environment not exceeding Vibration Criterion VC-C **Height Measurement Time** (1 Field of View, 10µm Scannin Height Measurement Range Lower of objective Lower of objective Lower of objective Lower of objective distance or 20mr distance or 20mm distance or 20m distance or 20mm Correction Plane Term Correction, Quartic Term Correction Digital Enlargement 1/100 sub-pixel processing Roughness Measurement 2-dimensional roughness (Ra, Rq, Rz), 3-dimensional roughness (Sa, Sq, Sz) Profile Display Cursor measurement of height, distance, and angle between two points; measurement of approximate circle radius of location specified in the profile Output Output of processed images and roughness indices to an Excel file **Automatic Processing** Automatic processing of multiple height images Three Dimensional Display With MS Direct X Other Analysis Software (Optional) Geometric Parameter Measurement, Zernike Polynomial Analyzer, Optical Ray Tracer, Surface Texture Analyzer, Layer Thickness Analyzer, Reference Surface Correction, Hole Shape Analyzer **Height Calibration** Standard step sample (optional) made by VLSI Standards Inc. Anti-vibration Mechanism (Optional) Active vibration isolation table or passive vibration isolation table 100-240+10%VAC Power Source Installation Space Approx. 1800(W) ×700(D) ×1600(H) mm Microscope Unit: Approx. 500(W) ×560(D) ×700(H) mm / Approx. 23 kg

Computer: Approx. 173(W) ×471(D)×414(H) mm / Approx. 20kg



Dimensions



Specifications and equipment are subject to change without any notice or obligation on the part of the manufacturer. March 2014 ©2014 NIKON CORPORATION

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TO ENSURE CORRECT USAGE, READ THE CORRESPONDING MANUALS CAREFULLY BEFORE USING THE EQUIPMENT.



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